



JFW / AFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Yoshihiro SUGITA et al.**

Group Art Unit: **2823**

Serial No.: **10/633,534**

Examiner: **Brook Kebede**

Filed: **August 5, 2003**

Confirmation No.: **6460**

For: **MANUFACTURE METHOD FOR SEMICONDUCTOR DEVICE
WITH PATTERNED FILM OF ZrO₂ OR THE LIKE**

Attorney Docket Number: **030862**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: March 29, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 16, 2004 for one month from March 16, 2005 to April 16, 2005.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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